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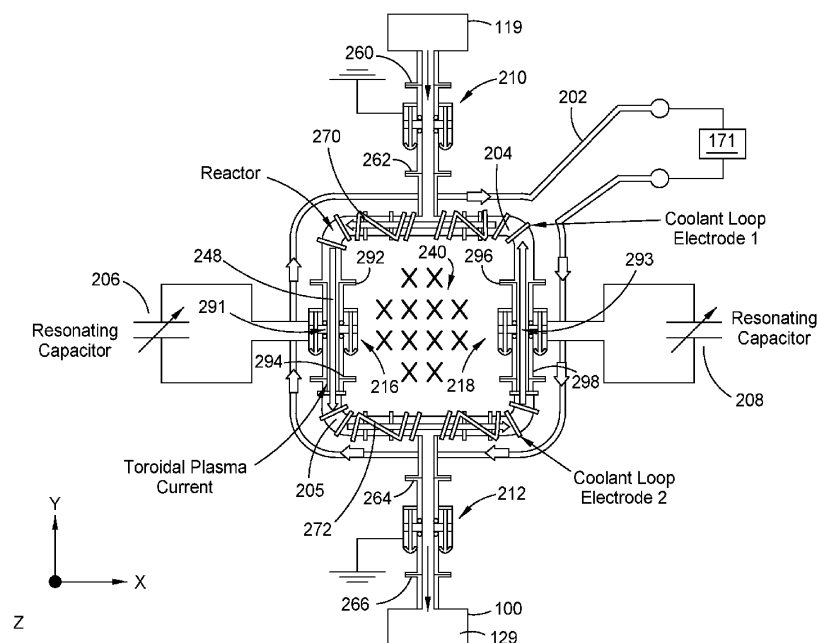
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(54) Title: REMOTE PLASMA SOURCE



(57) **Abstract:** Some embodiments are directed to a remote plasma system. The remote plasma system may include: a first tube; a second tube; a first isolation component coupled between a first end of the first tube and a first end of the second tube; a second isolation component coupled between a second end of the first tube and a second end of the second tube; and a first capacitive element coupled to the first isolation component.

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WO 2025/075849 A1

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